

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 10/082,599
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 Inventor Craig M. Carpenter et al.
 Assignee Micron Technology, Inc.
Priority Group Art Unit 1763
Priority Examiner Karla A. Moore
 Attorney's Docket No. MI22-2433
 Customer No. 021567
 Title: Semiconductor Substrate Processing Chamber and Accessory
 Attachment Interfacial Structure (as Amended)

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
 Commissioner for Patents
 P. O. Box 1450
 Alexandria, VA 22313-1450

VIA EXPRESS MAIL

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Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS

Amendments to the Title

Please change the title to the following: --SEMICONDUCTOR
SUBSTRATE PROCESSING CHAMBER AND ACCESSORY ATTACHMENT
INTERFACIAL STRUCTURE--.